SUPPLEMENTAL INFORMATION DISCLOSURE CITATION				Atty Docket 42496/0269250	Serial No. 09/941,360				
	PTO-1449	OIPE	4C11						
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Date Mailed: August 28, 2001			ARRE	Filing Date August 28, 2001 DOCUMENTS	Date 28, 2001		Group Art Unit: 1741		
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

SUPPLEMENTAL INFORMATION DISCLOSURE CITATION PTO-1449 Date Mailed: November, 2001				Atty Docket 42496/0269250	Serial No. 09/941,360			
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SUPPLEMENTAL INFORMATION				Atty Docket Serial No.					
DISCLOSURE CITATION			42496/0269250		09/941,360				
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Date Mailed: August 28, 2001			Applicant: Talieh, et al.						
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